



Differential, Gauge and Absolute Pressure Sensor (0 to 200 kPa)

MPXx2200

Last Updated: Dec 17, 2024

MPX2200 series pressure sensors offer silicon piezoresistive solutions for a variety of industrial and medical applications.

- Provides a highly accurate and linear voltage output directly proportional to the applied pressure
- Includes a single monolithic silicon diaphragm with the strain gauge and a thin-film resistor network integrated on-chip
- Delivers a laser-trimmed chip for precise span, offset calibration and temperature compensation

MPXX2200_BD Block Diagram

PACKAGING ORDERING INFORMATION

Device Type	Packing Options	Case
MPX2200A	Absolute, Differential	344
MPX2200D	Absolute, Differential	344
MPX2200DP	Differential	344C
MPX2200AP	Absolute, Gauge	344B
MPX2200GP	Absolute, Gauge	344B
MPX2200GVP	Gauge, Vacuum	344D

View additional information for [Differential, Gauge and Absolute Pressure Sensor \(0 to 200 kPa\)](#).

Note: The information on this document is subject to change without notice.

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